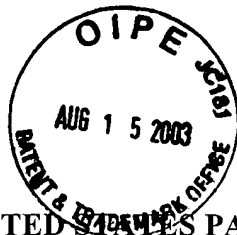


DOCKET: CU-3284

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jong Hwan KIM

Serial No.: 10/616,823

Group Art Unit:

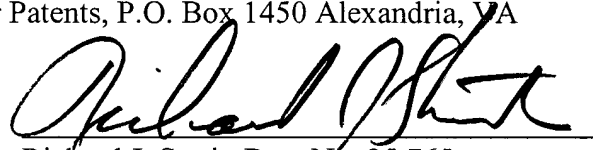
Filed: July 10, 2003

Examiner:

For: METHOD FOR FORMING BIT LINES OF SEMICONDUCTOR DEVICE

Certification under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to The Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on August 12, 2003.


Richard J. Streit, Reg. No. 25,765

The Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (IDS) WITHIN
THREE MONTHS OF FILING OR BEFORE MAILING OF FIRST OFFICE ACTION**

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of the first Office Action on the merits, whichever event occurs last. 37 CFR 1.97(b).

No fee is believed to be required in view of the above. However, if this is not the case, the Commissioner is authorized to charge our Deposit Account No. 12-0400 for any required fees.

Date:

8/12/03


Richard J. Streit, Reg. No. 25,765

Ladas & Parry
224 South Michigan Avenue
Chicago Illinois 60604
Tel. No. (312) 427-1300



DOCKET: CU-3284

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Richard J. Streit, Reg. No. 25,765

The Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT (IDS)

Applicant submits herewith patents, publications or other information of which the applicant is aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose under 37 CFR 1.56.

The USPTO has posted on their website that IDS's for applications filed after June 30, 2003 do not need to include copies of the US patent references. Accordingly, no paper copies of the U.S. patent references identified in this IDS are submitted herewith since the filing date of the present application is after June 30, 2003. Only the copies of foreign patent and/or other relevant publication references are submitted herewith.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

The references submitted herein are listed on PTO-1449 form (modified) enclosed herewith. A copy of each reference listed is being furnished except any duplicate or cumulative patents or publications specified otherwise.

A translation of any foreign language reference, if any, is indicated in PTO-1449 form and being submitted herein if it is readily available. Otherwise it should be construed that such translation is not readily available.

The Statement is made on the basis of the information:

- ☐ supplied by the inventor(s);
- ☒ supplied by an individual associated with the filing and prosecution of this application (37 CFR 1.56(c));
- ☐ in the attorney's file; or
- ☐ cited in a corresponding PCT, EPO, and/or foreign application, if any.

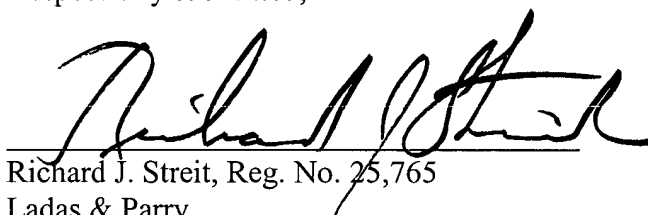
Additional comments, if any, on the relevance of each reference listed are provided as follows:

The Statement is made on the basis that the present submission of the IDS is before the mailing date of the first Office Action.

Respectfully submitted,

Date: _____

8/12/03



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Form PTO-1449 (Modified)

FORM PTO-1449	ATTY. DOCKET NO. CU-3284	SERIAL NO. 10/616,823
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))	Applicant Jong Hwan KIM	
	FILING DATE July 10, 2003	GROUP

U.S. PATENT OR PUBLISHED U.S. PATENT APPLICATION DOCUMENTS

EX. INITI AL		PATENT OR PUBLICATION NO.							ISSUE OR PUBLICATION DATE	PATENTEE OR APPLICANT	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
	US	6	4	1	7	0	5	5	07/09/02	Jang et al.			
	US	6	3	4	8	4	1	1	02/19/02	Ireland et al.			
	US	6	2	7	1	1	2	5	08/07/01	Yoo et al.			
	US	6	1	7	7	3	4	0	01/23/01	Yoo et al.			
	US	6	1	7	7	3	2	0	01/23/01	Cho et al.			
	US	6	0	3	7	2	1	6	03/14/00	Liu et al.			
	US	5	3	6	2	6	6	6	11/08/94	Dennison			
	US	5	9	4	6	5	6	8	08/31/99	Hsiao et al.			

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

EXAMINER INITIAL		DOCUMENT NUMBER							PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB- CLASS	TRANSLATION YES NO	

OTHER DOCUMENTS (Including Author, Title, Date, Place of publication)

Examiner	DATE CONSIDERED
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.